

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Michael HERZOG

Serial No: National Phase of
PCT/EP02/14699 Attorney Docket: HERZ3001/FJD

Filed: July 12, 2004

For: METHOD FOR MAINTAINING A PRODUCTION
INSTALLATION

Commissioner of Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to Rule 37 C.F.R. §1.51(b), §1.56, §1.97, and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 02-0200.

Respectfully submitted,



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Date: July 12, 2004

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B/O Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office	Atty. Docket Number HERZ3001/FJD	Serial Number 107500149 National Phase of PCT/EP02/14699
Information Disclosure Statement by Applicant	Applicant Michael HERZOG	Filing Date July 12, 2004
		Group Unassigned

<divUUdivU.S. Patent Documents!!!!!

Foreign Patent Documents

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		KUNZ, J C. ET AL: "Support for Integrated Value-Based Maintenance Planning", IEEE Expert, IEEE Inc., New York, NY, US, Bd. 11, Nr. 4, 1. August 1996.
		KOECHLIN J-B ET AL: "A conceptual data scheme for integrated maintenance: A map to design maintainable AMS" COMPEURO '93. 'COMPUTERS IN DESIGN, MANUFACTURING, AND PRODUCTION', PROCEEDINGS. PRIS-EVRY, FRANCE 24-27 MAY 1993, LOS ALAMITOS, CA, USA, IEEE COMPUT. SOC, US, 24. Mai 1993.

Examiner _____ *Date Considered* _____

EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.